



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#12/Amult
ATM
11/8/03
RECEIVED
NOV - 3 2003
TECHNOLOGY CENTER 2800

In re Application of: Christian Kratzsch et al.
Serial No.: 09/807,061
Filing Date: 07/09/2001
Title: METHOD FOR SHAPING MATERIALS WITH
PLASMA-INDUCING HIGH-ENERGY RADIATION
Group Art Unit: 2853
Examiner: Blaise L. Mouttet
Attorney's Docket No.: STUR-35

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED
WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL,
POSTAGE PREPAID, IN AN ENVELOPE ADDRESSED TO: COMMISSIONER
FOR PATENTS, PO BOX 1450, ALEXANDRIA, VA 22313-1450, ON:

October 28, 2003

(DATE OF DEPOSIT)

Scott R. Foster

(NAME OF ATTORNEY)

(SIGNATURE)

October 28, 2003

(DATE OF SIGNATURE)

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

This paper is submitted in response to an Office Action of
May 8, 2003.

Please amend the application as follows:

STUR-35